

Notice of References Cited

Application/Control No.

10/584,501

Applicant(s)/Patent Under

Reexamination

MEINDS ET AL.

Examiner

M GOOD JOHNSON

Art Unit

2628

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U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,985,156	01-2006	Wang et al.	345/582
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Ren et al., Object Space EWA Surface Splatting: A Hardware Accelerated Approach to High Quality Point Rendering, pages 461-470, EUROGRAPHICS, Volume 21, 2002.
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a))
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